



A *EBK/JBG*
REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 3723
145 07/06/03

PATENT
5298-05700/PM01016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Collier et al.

Serial No. 09/899,871

Filed: July 6, 2001

For: METHOD AND SYSTEM FOR
CLEANING A POLISHING PAD

§ Group Art Unit: 3723
§ Examiner: Wilson, L.

§ Atty. Dkt. No. 5298-05700

§ I hereby certify that this correspondence is being deposited with
§ the U.S. Postal Service with sufficient postage as First Class Mail
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§ Box 1450, Alexandria, VA 22313, on the date indicated below:

July 3, 2003
Date

KEVIN E. DAFFER
Kevin E. Daffer

RESPONSE AFTER FINAL REJECTION PURSUANT TO 37 CFR § 1.116

MS: AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

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JUL 09 2003

Dear Sir/ Madam:

TECHNOLOGY CENTER R3700

This paper is submitted in response to the Office Action dated May 7, 2003 to further highlight
reasons why the application is in condition for allowance.

Remarks/Arguments begin on page 2 of this paper.